

Search Notes

Application/Control No.

10/618,142

Examiner

David Y. Chung

Applicant(s)/Patent under
Reexamination

KIM ET AL.

Art Unit

2871


SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|----------|----------|
| 349 | 117 | 4/3/2005 | DC |
| 349 | 119 | 4/3/2005 | DC |
| 349 | 106 | 4/3/2005 | DC |
| 349 | 110 | 4/3/2005 | DC |
| 349 | 130 | 4/3/2005 | DC |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|--|----------|------|
| Consulted Ken Parker  | 4/1/2005 | DC |
| EAST search report | 4/4/2005 | DC |
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